

# Contents

<b>Preface</b>	<b>ix</b>
<b>Acknowledgements</b>	<b>xi</b>
<b>Introduction</b>	<b>1</b>
<i>R K Fitch</i>	
<b>1 Gases</b>	<b>5</b>
<i>A Chambers</i>	
Introduction	5
1.1 Molecules	5
1.2 Bonding	6
1.3 Ions	7
1.4 Masses of atoms and molecules	7
1.5 Bonding, energy and temperature. Solids, liquids and gases	9
1.6 The kinetic description of a gas	10
1.7 Results from kinetic theory	11
1.8 Vapour pressure	14
1.9 Gases and vapours	16
1.10 Macroscopic gas laws	17
1.11 Gas mixtures and partial pressures	18
Summary	19
References	19
General reading	19
<b>2 Gases in vacuum systems</b>	<b>20</b>
<i>A Chambers</i>	
Introduction	20
2.1 The basic task, units and ranges of vacua	20
2.2 Formulas for important quantities	22
2.3 Qualitative description of the pumping process	23
2.4 Surface processes and outgassing	25
2.5 Gas flow: formalities	30
2.6 Gas flow: mechanisms	35
2.7 Molecular flow conductance of an aperture	39
2.8 Maximum speed of a pump in the molecular flow region	40
2.9 Molecular flow through pipes; transmission probability and conductance	41
2.10 Quantitative description of the pumping process	46
Summary	49
References	49
<b>3 Pumps</b>	<b>51</b>
<i>B S Halliday</i>	
Introduction	51
3.1 Positive displacement pumps	51
3.2 Kinetic pumps	55

vi	<i>Contents</i>	
3.3	Entrapment pumps	61
3.4	Pump selection	70
	Summary	71
<b>4</b>	<b>Measurement of pressure</b>	<b>72</b>
	<i>R K Fitch</i>	
	Introduction	72
4.1	Total pressure gauges	72
4.2	Liquid level manometers	72
4.3	Thermal conductivity gauges	73
4.4	Ionisation gauges	74
4.5	Capacitance manometer gauges	81
4.6	Spinning rotor gauge (SRG)	82
4.7	Calibration of vacuum gauges	84
4.8	Partial pressure gauges	86
4.9	The magnetic sector analyser	87
4.10	The quadrupole residual gas analyser	88
4.11	Display of spectra	91
4.12	Interpretation of spectra	92
	Summary	93
	References	94
<b>5</b>	<b>Vacuum materials and components</b>	<b>96</b>
	<i>B S Halliday</i>	
	Introduction	96
5.1	Properties required	96
5.2	Commonly used materials	97
5.3	Seals	99
5.4	Ceramics and glasses	101
5.5	Pump fluids	101
5.6	Flanges	102
5.7	Fittings	106
5.8	Machining and construction of components	112
	Summary	113
	Bibliography	114
<b>6</b>	<b>Cleaning</b>	<b>115</b>
	<i>B S Halliday</i>	
	Introduction	115
6.1	General considerations	115
6.2	Procedure selection	117
6.3	Cleaning procedures	118
6.4	Packaging	122
6.5	General cleaning techniques	123
6.6	Special cleaning processes	123
6.7	Cleaning of vacuum components and plant after use	124
	Summary	125

<b>7</b>	<b>Leaks and leak detection</b>	<b>127</b>
	<i>R K Fitch</i>	
	Introduction	127
7.1	Real and virtual leaks	127
7.2	Methods of leak detection	129
7.3	Leak detectors	130
	Summary	136
	References	136
<b>8</b>	<b>Systems</b>	<b>137</b>
	<i>B S Halliday</i>	
	Introduction	137
8.1	Simple rotary pumped systems	137
8.2	Diffusion pumped system	138
8.3	A turbo molecular pumped system	139
8.4	Ultra-high vacuum system	140
8.5	A cryo pumped system	141
8.6	A large volume fully automated multi-pumped system	142
8.7	A particle accelerator pumping system	143
	Summary	144
	Reference	144
	<b>Appendices</b>	<b>145</b>
	<b>Further reading lists</b>	<b>153</b>
	<b>Standard graphic symbols</b>	<b>157</b>
	<b>List of symbols used in the text</b>	<b>158</b>
	<b>List of units used in the text</b>	<b>161</b>
	<b>Index</b>	<b>163</b>